

Electronic Acknowledgement Receipt

EFS ID:	3133223
Application Number:	10518371
International Application Number:	
Confirmation Number:	6811
Title of Invention:	Plasma chemical vapor deposition method and plasma chemical vapor deposition device
First Named Inventor/Applicant Name:	Hiroshi Mashima
Customer Number:	22850
Filer:	Marvin Jay Spivak/Igmar Sorto
Filer Authorized By:	Marvin Jay Spivak
Attorney Docket Number:	263787US2PCT
Receipt Date:	10-APR-2008
Filing Date:	28-DEC-2004
Time Stamp:	14:38:45
Application Type:	U.S. National Stage under 35 USC 371

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part/.zip	Pages (if appl.)
1		263787USIDS1.pdf	1437312 b98e0bdab20d9f41458418caaa27d7 4582044	yes	29

Multipart Description/PDF files in .zip description			
Document Description	Start	End	
Information Disclosure Statement Letter	1	1	
Information Disclosure Statement (IDS) Filed	2	2	
NPL Documents	3	5	
Foreign Reference	6	25	
Foreign Reference	26	29	

Warnings:

Information:

Total Files Size (in bytes):	1437312
------------------------------	---------

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.